

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination SHINO ET AL.	
		Examiner Danny Wai Lun Leung	Art Unit 2633	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-5,432,874	07-1995	Muraguchi, Takahiro	385/24
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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